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10-07-1998

PATENT REEL: 9487 FRAME: 0448

Attorney Docket No.: 39205-64

**RECORDED: 09/25/1998** 

## ASSIGNMENT OF PATENT APPLICATION

For value received, the undersigned sell(s), assign(s) and transfer(s) to:

## Institute of Microelectronics

a corporation organized under the laws of: Singapore and having a place of business at: 11 Science Park Road, Science Park II, Singapore 117685 and to Assignee's successors, assigns and legal representatives or nominees as it may designate (collectively, hereinafter, "Assignee"), the entire right, title and interest, for:			
The United States of America and Its  Territories and Commonwealth and Possessions  X All countries throughout the world			
in and to all inventions and improvements disclosed in an application for United States Patent entitled:			
WAFER SCALE BURN-IN TESTING			
The above-entitled United States Patent application was:			
executed by the undersigned on:  August 5, 1998  filed in the United States Patent and Trademark Office on:  and assigned serial number:			
filed as PCT International Application No.:on:			
The undersigned assign(s) the rights for all patents, divisions, reissues, reexamination certificates, continuing applications and extensions thereof, together with the right of priority of any earlier corresponding patent application filed by the undersigned in the United States or elsewhere.  The undersigned covenant(s) that the rights and property conveyed by this Assignment are free and clear of any encumbrance, and that the undersigned have (has) full right to convey the rights and property as expressed herein.			
The undersigned authorize(s) and request(s) that any and all patents on the aforesaid inventions be issued to Assignee.			
The undersigned agree(s), when requested, without further charge to Assignee but at its expense, to communicate to Assignee or its representatives all facts known to the undersigned regarding the aforesaid inventions and improvements, testify in any legal proceeding, sign all papers, make all rightful oaths or declarations, execute all divisional, continuing, re-examination and reissue applications and generally perform all acts, which may be necessary, desirable or convenient, to aid Assignee in securing, maintaining and enforcing patents for the aforesaid inventions and improvements in the aforesaid countries, and for vesting title thereto in Assignee.  Date: Two 181818			
Date: June 18/118 Shun Shen Peter Wang			

**PATENT REEL: 9487 FRAME: 0449**